



Docket No.: 283485US0PCT



COMMISSIONER FOR PATENTS
ALEXANDRIA, VIRGINIA 22313

ATTORNEYS AT LAW

RE: Application Serial No.: 10/562,265
Applicants: Masatomo SUMIYA, et al.
Filing Date: May 24, 2006
For: METHOD FOR GROWING THIN NITRIDE FILM ONTO
SUBSTRATE AND THIN NITRIDE FILM DEVICE
Group Art Unit: 1794
Examiner: LANGMAN, JONATHAN C.

SIR:

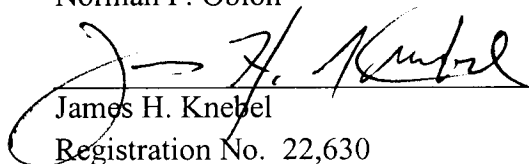
Attached hereto for filing are the following papers:

Response to the Requirement for Restriction

Credit card payment is being made online (if electronically filed), or is attached hereto (if paper filed), in the amount of **\$0.00** to cover any required fees. In the event any variance exists between the amount enclosed and the Patent Office charges for filing the above-noted documents, including any fees required under 37 C.F.R. 1.136 for any necessary Extension of Time to make the filing of the attached documents timely, please charge or credit the difference to our Deposit Account No. **15-0030**. Further, if these papers are not considered timely filed, then a petition is hereby made under 37 C.F.R. 1.136 for the necessary extension of time.

Respectfully submitted,

OBLON, SPIVAK, McCLELLAND,
MAIER & NEUSTADT, P.C.
Norman F. Oblon



James H. Knebel
Registration No. 22,630

Customer Number

22850

(703) 413-3000 (phone)
(703) 413-2220 (fax)
(OSMMN 10/08)